



ZFW/KS
PATENT
Attorney Docket No. 402721

In re Application of: WATANABE et al.
 Application No. 10/627,611
 Filed: July 28, 2003
 For: METHOD OF FABRICATING X-RAY MASK AND METHOD OF FABRICATING SEMICONDUCTOR DEVICE USING THE X-RAY MASK

U.S. Patent and Trademark Office
 Customer Service Window, Mail Stop Amendment
 Randolph Building
 401 Dulany Street
 Alexandria, VA 22314

Sir:

Small entity status is claimed for this application under 37 CFR 1.27.

Petition for an extension of time for the period noted below, as well as for any additional period necessary to render the present submission timely. Please charge Deposit Account No. 12-1216 for the appropriate petition fee.

Other:

Please charge Deposit Account No. 12-1216 in the total amount indicated below. A duplicate copy of this transmittal sheet is enclosed herewith.

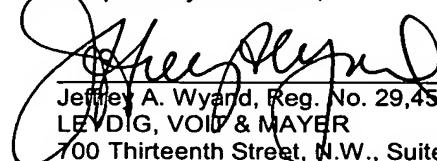
					SMALL ENTITY	OTHER THAN A SMALL ENTITY		
TIME EXTENSION PETITION FEE		none			\$ 0.00	\$ 0.00		
	subtract time extension fee previously paid	none			(\$ 0.00)	(\$ 0.00)		
CLAIM FEE	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR	EXTRA CLAIMS PRESENT	RATE	ADD'L CLAIM FEE	RATE	
TOTAL	18	MINUS	20	= 0	x 25=	\$	x 50=	\$
INDEPENDENT	7	MINUS	3	= 4	x 100=	\$	x 200=	\$800.00
<input type="checkbox"/>	FIRST PRESENTATION OF MULTIPLE CLAIM				+ 180=	\$	+ 360=	\$
TOTAL AMOUNT TO BE CHARGED TO DEPOSIT ACCOUNT					TOTAL	\$	TOTAL	\$800.00

The Commissioner is hereby authorized to charge any deficiencies in the following fees associated with this communication or credit any overpayment to Deposit Account No. 12-1216.

Any filing fees under 37 CFR 1.16 for the presentation of extra claims.

Any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,


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Date: October 17, 2006
 JAW:ves